Notice of References Cited Application/Control No. 10/539,884 Examiner DIMPLE N. BODAWALA Applicant(s)/Patent Under Reexamination YAMAGUCHI ET AL. Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-3,704,176 A	11-1972	Oga et al.	428/422
*	В	US-3,785,946 A	01-1974	Shiro et al.	205/188
*	C	US-4,968,389 A	11-1990	Satoh et al.	205/106
*	D	US-6,066,392 A	05-2000	Hisamoto et al.	428/304.4
*	Е	US-2002/0109134 A1	08-2002	Iwasaki et al.	257/13
*	F	US-6,444,304 B1	09-2002	Hisamoto et al.	428/319.1
*	G	US-6,565,984 B1	05-2003	Wu et al.	428/472.2
*	Η	US-6,818,118 B2	11-2004	Kinlen et al.	205/317
	-	US-			
	J	US-			
	K	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Ø					
	R					
	Ø					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Xue et al., "Evaluation of the mechanical properties of microarc oxidation coating and 2024 aluminum alloy substrate", 25 October 2002, Institute of Physic Publishing, Condensed Matter 14 (2002) 10947-10952.			
	V				
	w				
	x				

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.